



Attorney Docket No. 59521 (48229)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Hiroyuki Shimada

EXAMINER: Chen Kin Chan

U.S.S.N.: 10/678,994

GROUP ART UNIT: 1765

FILED: October 3, 2003

CONFIRMATION NO.: 8918

FOR: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE
INCLUDING ETCHING A CONDUCTIVE LAYER BY USING A GAS
INCLUDING SiCl₄ and NF₃

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By

Nicole M. McKinnon
Nicole M. McKinnon

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Arlington, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In response to the Office Action dated October 31, 2005, Applicant submits
the following amendment.

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